

Design and simulation of hybrid SET-CMOS logic inverter using macro-model technique

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The single-electron transistor (SET) is one of the state-of-the-art devices that can offer high operating speed with ultra-low power consumption. The SET macro-modeling, can be used for the simulation of a SET-CMOS logic circuit. In this work, we develop a new hybrid, SET-CMOS logic inverter macro-model whose effect is very useful in VLSI circuits design. All simulations are performed using the SIMSCAPE environment of MATLAB SIMULINK. This architecture has been realized by implementing the NMOS logic of the conventional inverter with a SET macro-model. The simulation results show that the hybrid structure offers better performance. Indeed, the designed circuit is able to operate at room temperature.

Keywords: Single electron transistor (SET); macro-modeling; simscape; logic Inverter; hybrid SET-CMOS logic.

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1. Introduction

For the improvement of very large scale integration devices (VLSI), circuit miniaturization is a great challenge for researchers [1-3]. Indeed, reducing the dimensions of MOSFETs to the nanometric scale poses problems. For example, increased power consumption and electric fields in the MOSFET channel can cause barrier rupture and therefore higher leakage currents which can damage the device. With the advancement in technology, CMOS has been manufactured [4]. However, reducing the size of the MOS transistor leads to fundamental physical effects: short channel effect [5], gate oxide and high field effects [6,7]. These issues have led to the exploration of possible successor technologies with greater scalability potential, such as single electron device (SET) technology [8-11]. SETs have recently gained a lot of attention because of their nanoscale ultra-low power dissipation [12-16]. Despite these interesting properties, the SET has integration limits. The principal problem is that the operation of a SET at room temperature requires extremely small island capacities, thus which in practice means a smaller than nanometer island size for room temperature operation [17]. The second major problem with single electron electronic components is randomness of the background charge. Indeed, a single charged impurity trapped in the insulating environment polarizes the island, creating on its surface an image charge of the order of e . This load is effectively subtracted from the external load [18]. Hybridization of SET with CMOS technology has emerged as a promising candidate for the next generation ultra-small [19-21], low-power, high-speed Nano device. To understand the characteristics of SET-based circuits and explore its applications, simulation and modeling of this device has become of great importance [22-25]. SET simulation in general is based on

three approaches, analytical modeling [26], macro-modeling [27] and the Monte Carlo method [28]. In this work, we proposed a hybrid SET-NMOS logic inverter macro-model using Simulink MATLAB. NMOS is used in our model due to some inherent performance advantages [29]. Such as the mobility of electrons, which are the carriers in the case of an n-channel device, is about two times greater than that of holes, which are the carriers in the p-channel PMOS device. Thus an n-channel NMOS device is faster than a p-channel PMOS device. This paper is structured as follows. In Sec. 2, we propose a hybrid of SET-CMOS logic macro-model. The simulation results are discussed in this Sec. 3. The overall work is concluded in the last section.

2. Design of the proposed model of hybrid SET-CMOS logic

SET are three-terminal switching devices. A schematic structure and equivalent circuit of a SET is shown in Fig. 1, where the source (S), the drain (D) and the gate (G) are the three terminals. The two tunnel junctions, their corresponding tunnel resistance and capacitances, are also illustrated.

Note that R_d is the resistance of the drain tunnel junction, R_s is the tunnel resistance of the source, C_d is the capacitance of the drain tunnel junction, C_s is the capacitance of the source tunnel junction and C_g is the capacitance of the gate. The two tunnel junctions are created by a Coulomb island or Quantum dot (QD), that electrons can only enter by tunneling through one of the tunnel junctions.

The gate terminal is capacitively coupled to the node between the two tunnel junctions. The capacitor may seem like a third tunnel junction, but it is much thicker than the others so that no electrons can tunnel through it. The capacitor simply serves as a way of setting the electric charge on the

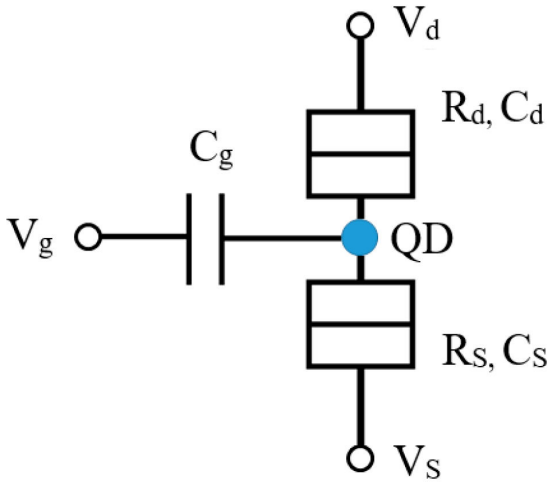


FIGURE 1. Equivalent electrical model of a SET.

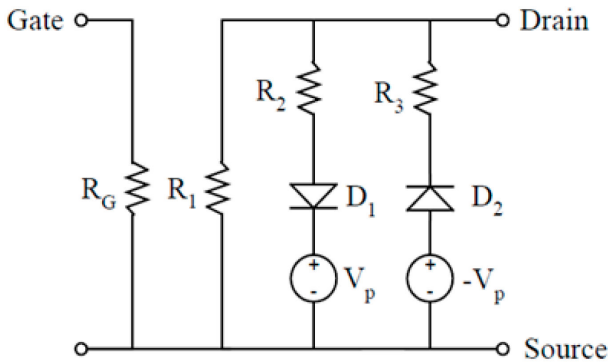


FIGURE 2. Macro-model proposed by Yu *et al.*, [30].

coulomb island. In our model of hybrid SET-MOS logic, the equivalent circuit of an SET is shown in Fig. 2. The charge energy changes periodically depending on the gate bias. This energy is included in the resistors R_1 , R_2 and R_3 , which are expressed as follows [30]:

$$R_1(V_g) = CR_1 + CR_2 \cos(CF_1 \cdot V_g), \quad (1)$$

and

$$R_2(V_g) = R_3(V_g) = \frac{CV_p}{CI_2 - \frac{2CV_p}{R_1(V_g)}}, \quad (2)$$

where CR_1 , CR_2 , CV_p , CI_2 and CF_1 are different parameters used to adjust the input and output current-voltage characteristics.

The inverter model proposed in Fig. 3, designed by Simscape, consists of an NMOS, whose source is connected to ground, and a SET macro-model that replaces the PMOS. A square input signal of 0 to 5 V is applied as input voltage to the common gate of the NMOS and SET.

The purpose of the two combinations R_2 , V_1 , D_1 , and R_3 , V_2 , D_2 is to obtain an adequate current onset in the positive and negative directions for different values of V_{ds} .

3. Simulation results

Figure 4 shows the simulation results of the designed circuit. The input signal V_{in} and output signal V_{out} are shown in the same figure. The signal obtained at the output changes depending on the value of the input signal, these characteristics are given in Fig. 4. When the input voltage of the gate is low, NMOS is activated and SET is deactivated. For this reason, a high output voltage is obtained. Similarly, when a high input voltage is applied to the gate terminal, opposite phenomena occur and a low output voltage is obtained at the output terminal.

The power consumed by the hybrid SET-CMOS logic proposed is given in Table I. By comparing the performance of the designed SET-CMOS logic hybrid circuit with its CMOS logic counterpart in terms of energy consumption. We deduce that the power consumption is less in Hybrid CMOS-SET logic technology (35.59 nW) than CMOS logic technology (120.4 nW).

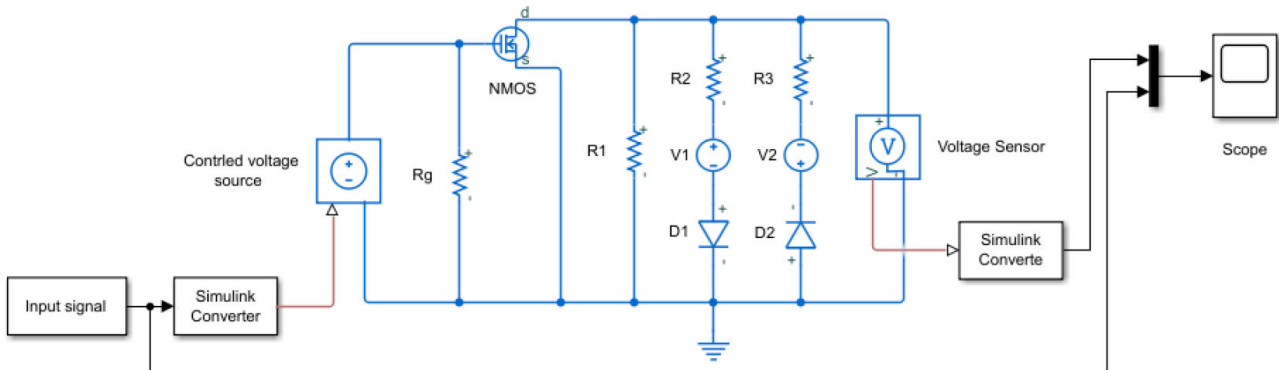


FIGURE 3. Macro-model of the proposed hybrid SET-CMOS logic inverter.

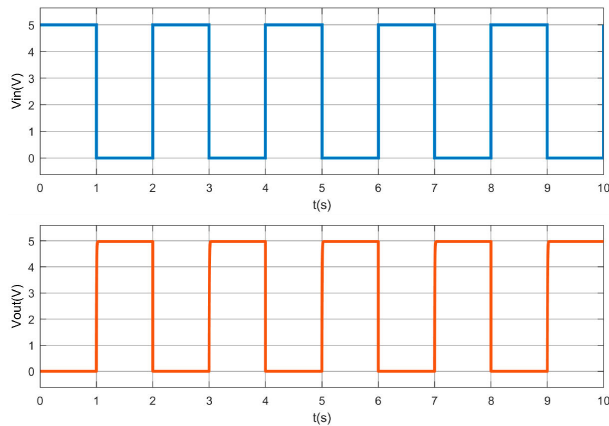


FIGURE 4. Simulation results of hybrid SET-CMOS logic Inverter.

TABLE I. Comparison of power consumption between proposed hybrid SET-CMOS logic based inverter circuit and CMOS based inverter circuit.

Inverter logic model	Hybrid SET-CMOS logic inverter	CMOS logic Inverter
Average electrical power consumption (10^{-9} W)	35.59	120.4

4. Conclusions

The macro-modeling of SET accompanied with CMOS gives a new direction in the evolution of research work on nano devices. The proposed inverter, replacing the PMOS by the SET macro-model, has a new hybrid SET-CMOS logic architecture, which offers ultra-low electrical power dissipation, high response speed and also improved operation in the low voltage region. The performance of the proposed inverter is verified by simulation in Matlab Simulink's Simscape environment, which is capable of efficiently simulating hybrid SET-CMOS logic circuits on a very large scale. The results obtained are promising enough to increase its reliability and to justify the use of the model in the design of ultra-dense electronic logic circuits.

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